

<b>Notice of References Cited</b>	Application/Control No. 10/584,501	Applicant(s)/Patent Under Reexamination MEINDS ET AL.	
	Examiner M GOOD JOHNSON	Art Unit 2628	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,985,156	01-2006	Wang et al.	345/582
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Ren et al., Object Space EWA Surface Splatting: A Hardware Accelerated Approach to High Quality Point Rendering, pages 461-470, EUROGRAPHICS, Volume 21, 2002.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.